



**ELECTRONIC COPY**

LG797677276  
Report verification at igi.org



May 18, 2026

IGI Report Number **LG797677276**

Description **LABORATORY GROWN DIAMOND**

Shape and Cutting Style **SQUARE EMERALD CUT**

Measurements **5.69 X 5.59 X 3.70 MM**

**GRADING RESULTS**

Carat Weight **1.07 CARAT**

Color Grade **E**

Clarity Grade **VVS 2**

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**ADDITIONAL GRADING INFORMATION**

Polish **EXCELLENT**

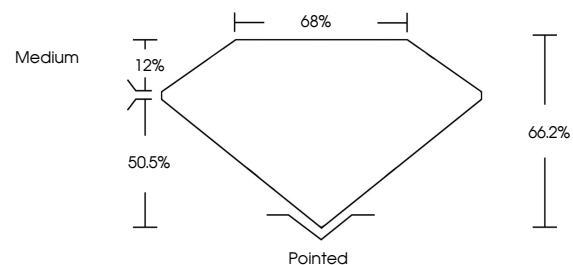
Symmetry **EXCELLENT**

Fluorescence **NONE**

Inscription(s) **IGI LG797677276**

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.  
Type IIa

**PROPORTIONS**



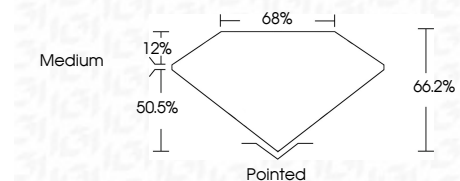
Sample Image Used

**COLOR**

D E F G H I J Faint Very Light Light

**CLARITY**

| FL       | IF                  | VVS <sup>1-2</sup>          | VS <sup>1-2</sup>      | SI <sup>1-2</sup> | I <sup>1-3</sup> |
|----------|---------------------|-----------------------------|------------------------|-------------------|------------------|
| Flawless | Internally Flawless | Very Very Slightly Included | Very Slightly Included | Slightly Included | Included         |



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Polish **EXCELLENT**

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**SQUARE EMERALD CUT**  
1.07 CARAT **E**  
Carat Weight **VVS 2**  
Color Grade **66.2%**  
Clarity Grade **65%**  
Table **Medium**  
Depth **Pointed**  
Girdle **EXCELLENT**  
Culet **EXCELLENT**  
Polish **EXCELLENT**  
Symmetry **NONE**  
Fluorescence **NONE**  
Inscription(s) **IGI LG797677276**

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